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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	OLP) Aı	rt Unit: 2882
David BERMAN, et al.	0)) Ex	caminer: (N/A)
Serial No.: 10/689,314	(DEC 2 0 2004 S.))) W	ashington, D.C.
Filed: October 20, 2003	RADEMARK RET)	·
For: X-RAY REFLECTOM FILM LAYERS WITH ACCURACY)) Do	ocket No.: 22350/21

INFORMATION DISCLOSURE STATEMENT [IDS]

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

This Information Disclosure Statement is submitted in accordance with 37 C.F.R. 1.97, 1.98, and it is requested that the information set forth in this statement and in the listed documents be considered during the pendency of the above-identified application, and any other application relying on the filing date of the above-identified application or cross-referencing it as a related application.

[X] 1. This IDS should be considered, in accordance with 37 C.F.R. 1.97, as it is filed:

(Check one of the boxes A-D)

[] A. within three months of the filing date of the above-identified national application or within three months of the entry into the national stage of the above-identified international application.

- [X] B. before the mailing date of a first office action on the merits.
- [] C. after (A) and (B) above, but before final rejection or allowance, and Applicants have made the necessary certification (box "i" below) or paid the necessary fee (box "ii" below).

(check one of the boxes "i" and "ii" below:)

[] i. Counsel certifies that, upon information and belief, each item of information listed herein was either (a) cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this IDS; or (b) was not cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of undersigned after making reasonable inquiry, was not known to any individual designated in 1.56(c) more than three months prior to the filing of this IDS.

"Express Mail" mailing label No. |EL 996367836 US Date of Deposit: |December 20, 2004 |
I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Name: Vivian Campbell

Signature: William Capappell

[] ii. A check for the fee set forth in 1.17(p), presently believed to be \$240, is enclose (check no).
[] D. after (A), (B) and (C) above, but before payment of the issue fee: Applicant petition under 37 C.F.R. 1.97(d) for the consideration of this IDS. A check for the fee set forth in §1.17(i) presently believed to be \$130 is enclosed (check no
[] 2. In accordance with 37 C.F.R. 1.98, this IDS includes a list (e.g., form PTO-1449) all patents, publications, or other information submitted for consideration by the office, eith incorporated into this IDS or as an attachment hereto. A copy of each document listed is attache except as explained below.
(check boxes A and/or B and fill in blanks, if appropriate.) [] A. Document(s) is (are) deemed substantially cumulative to document(, and, in accordance with 1.98(c), only a copy of each of the latter documents enclosed.
[] B. Certain documents were previously cited by or submitted to the Office in the following prior application(s), which are relied upon under 35 U.S.C. 120:
[insert serial numbers and filing dates of prior applications]
Applicant identifies these documents by attaching hereto copies of the forms PTO-892 and PTO-144 from the files of the prior application(s) or a fresh PTO-1449 listing these documents, and reque that they be considered and made of record in accordance with 1.98(d). Per 37 CFR 1.98(d), copies these documents need not be filed in this application.
[] 3. Document(s)is(are) not in the English language. In accordance wi 1.98(c), Applicant states:
[] An English translation of each document (or of the pertinent portions thereof), or a copof each corresponding English-language patent or application, or English-language abstract (or claim) is enclosed.
[] A concise explanation of the relevance of document(s) is found in the attaches search report (see reply to Comment 68 in the preamble to the final rules; 1135 OG at 20).
[] A concise explanation of the relevance of document(s) is set forth as follows: [Insert concise explanation of relevance]
[] A concise explanation of the relevance of document(s) can be found of page(s) of the specification.
[] A concise explanation of document(s) can be found on the attached sheet.

- 4. No explanation of relevance is necessary for documents in the English language (see reply to Comments 67 and 68 in the preamble to the final rules; 1135 OG 13 at 20).
 - [] 5. Other information being provided for the examiner's consideration follows:
- 6. In accordance with 37 C.F.R. 1.97(g) and (h), the filing of this IDS should not be construed as a representation that a search has been made or that information cited is, or is considered to be, material to patentability as defined in §1.56 (b), or that any cited document listed or attached is (or constitutes) prior art. Unless otherwise indicated, the date of publication indicated for an item is taken from the face of the item and Applicant reserves the right to prove that the date of publication is in fact different.

CROSS REFERENCE UNDER 37 C.F.R. §1.78 TO RELATED APPLICATIONS

Pursuant to 37 C.F.R. § 1.78, Applicant notes that the above-identified patent application may be related to the following U.S. Patent Applications:

Please also acknowledge receipt of the enclosed documents by stamping the enclosed postcard and returning same to us.

Please charge any outstanding amount or credit of any overpayment to Deposit Account No. 01-1785.

A duplicate copy of this letter is enclosed.

Respectfully submitted,

Řeg. No. 25,829

AMSTER, ROTHSTEIN & EBENSTEIN LLP

MJB:BMH/vc Encls.

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FORM PTO-1449 (Colb)		ATTY DOCKET NO.		SERIAL NUMBER 10/689,314				
			22350/21					
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS' INFORMATION STATEMENT			APPLICANT		examiner (N/A)			
			David BERMAN, et al.					
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Examiner's Initials	DOCUMENT NO.	DATE		NAME	CLASS SUE		FILING DATE	
AA	2004/0218717							
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AE	Chihah et al "N			s for Grazing X-Ra		tometry in	the Angle-	
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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS' INFORMATION STATEMENT			APPLICANT David BERMAN, et al. FILING DATE			EXAMINER (N/A) GROUP ART UNIT		
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		OTHER A	RT (Inclu	ding A	Author, Bills, Pertinent P	ages, Etc.)	1	•
	AE	Jaklevic, et al., "Energy Dispersive X-Ray Fluorescence Spectrometry Using Pulsed X-Ray Excitation", Advances in X-Ray Analysis 19 (1976). pp. 253-265.						
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